

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10628174			
<b>Filing Date:</b>	28-Jul-2003			
<b>Title of Invention:</b>	Procedure for etching of materials at the surface with focussed electron beam induced chemical reaction at said surface			
<b>First Named Inventor/Applicant Name:</b>	Hans Wilfried Peter Koops			
<b>Filer:</b>	Kenneth Lowell Mitchell			
<b>Attorney Docket Number:</b>	8183			
Filed as Small Entity				
<b>Utility      Filing Fees</b>				
<b>Description</b>	<b>Fee Code</b>	<b>Quantity</b>	<b>Amount</b>	<b>Sub-Total in USD(\$)</b>
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
Notice of appeal	2401	1	255	255
Post-Allowance-and-Post-Issuance:				
<b>Extension-of-Time:</b>				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 1 month with \$0 paid	2251	1	60	60
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>315</b>